

PATENT APPLICATION
Docket No. 9898-314
Client No. SS-20035-US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Won-Jun Lee, et al.
Serial No.: 10/763,356 Examiner: Alanko, Anita Karen
Filed: January 23, 2004 Art Unit: 1765
Conformation No. 7097
For: ETCHING METHOD FOR MANUFACTURING
SEMICONDUCTOR DEVICE

INFORMATION DISCLOSURE CITATION
FORM PTO-1449 (Modified)U.S. PATENT DOCUMENTS

Exam Init	Ref	Document Number	Issue Date	Name	Class	Sub Class
_____	_____					

FOREIGN PATENT DOCUMENTS

Exam Init	Ref	Document Number	Publication Date	Country	Name
AA	_____	EP 0595360 A1	May 4, 94	Europe	Saeki, Takanori
AA	_____	DE4307725	Sep. 16, 93	Germany	Dennison Charles H. et al.
AA	_____	DE4412086	Oct. 13, 94	Germany	Tae-Hyuk AHN. et al.

OTHER DOCUMENTS

Exam Init	Ref	Author, Title, Date, Pertinent Pages, Etc.)
AA	_____	English language abstract of German Publication No. DE4307725
AA	_____	English language abstract of German Publication No. DE4412086

Examiner: _____/Anita Alanko/

Date Considered: 06/06/2006